

500.41316VX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. KAJI, et al  
Serial No.: 10/090,759  
Filed: September 11, 2003  
For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS  
AND PLASMA PROCESSING METHOD USING IT

**PRELIMINARY AMENDMENT**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 11, 2003

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment to the Title;  
Amendments to the Specification and Abstract;  
Amendments to the Claims;  
Remarks are included following the amendments.